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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Date of Deposit:	February 18, 2005
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Name:	Gerri Renner
Signature:	<i>Gerri Renner</i>

Applicant : Ben Eynon
Serial No. : 10/733,723
Filing Date : December 11, 2003
Title: : FUSED SILICA PELLICLE IN INTIMATE CONTACT
WITH THE SURFACE OF A PHOTOMASK
Customer No. : 1912
Group Art Unit : 1756
Attorney Docket No.: 67493/64
Examiner : Rosasco, Stephen D.

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant respectfully inquires as to the status of the above-identified application. The last correspondence received from the U.S. Patent Office was our Return Receipt Postcard dated January 21, 2005 acknowledging receipt of an Information Disclosure Statement and Form PTO/SB/08A and a copy of U.S. Provisional Patent Application No. 60/283,114, filed April 11, 2001 by Franklin D. Kalk, entitled: "METHOD AND APPARATUS FOR COUPLING A PELLICLE FRAME TO A PHOTOMASK SUBSTRATE". To date, we have not received any further correspondence.

Respectfully submitted,

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Dated: New York, New York
302004.1 February 18, 2005